

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q78519

Kenshiro NAKASHIMA, et al.

Appln. No.: Not Yet Assigned
Divisional of 10/105,269 filed March 26, 2002

Confirmation No.: Not Yet Assigned

Group Art Unit: 2818 (parent)

Filed: November 24, 2003

Examiner: Long K. Tran (parent)

For: ELECTRODE FOR SILICON CARBIDE SEMICONDUCTOR, SILICON CARBIDE SEMICONDUCTOR ELEMENT COMPRISING THE ELECTRODE, AND PRODUCTION METHOD THEREFOR

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified application as follows on the accompanying pages.

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